

INVENTOR INFORMATION

Inventor One Given Name: Shinichi
Family Name: HARA
Postal Address Line One:
City of Residence: Saitama
State or Province of Residence: Saitama
Country of Residence: Japan
Citizenship Country: Japan

Inventor Two Given Name: Yutaka
Family Name: TANAKA
Postal Address Line One:
City of Residence: Tochigi
State or Province of Residence: Tochigi
Country of Residence: Japan
Citizenship Country: Japan

Inventor Three Given Name: Kazuyuki
Family Name: KASUMI
Postal Address Line One:
City of Residence: Tochigi
State or Province of Residence: Tochigi
Country of Residence: Japan
Citizenship Country: Japan

Inventor Four Given Name: Toru
Family Name: HIRABAYASHI
Postal Address Line One:
City of Residence: Tokyo
State or Province of Residence: Tokyo
Country of Residence: Japan
Citizenship Country: Japan

CORRESPONDENCE INFORMATION

Correspondence Customer Number: 05514
Fax: (212) 218-2200

APPLICATION INFORMATION

Title Line One: EXPOSURE APPARATUS, GAS REPLACEMENT METHOD,
Title Line Two: SEMICONDUCTOR DEVICE MANUFACTURING METHOD,
Title Line Three: SEMICONDUCTOR MANUFACTURING FACTORY AND EXPOSURE
Title Line Four: APPARATUS MAINTENANCE METHOD

Total Drawing Sheets: 14
Formal Drawings?: Yes
Application Type: Utility
Docket Number: 862.C2167
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number: 5514

PRIOR FOREIGN APPLICATION

Foreign Application One: 2000-093686
Filing Date: 03-30-2000
Country: JAPAN
Priority Claimed: Yes

INVENTOR INFORMATION (Cont'd)

Foreign Application Two: 2001-085531

Filing Date: March 23, 2001

Country: JAPAN

Priority Claimed: Yes

2001-085531